# Edwards EPX-180, EPX-500

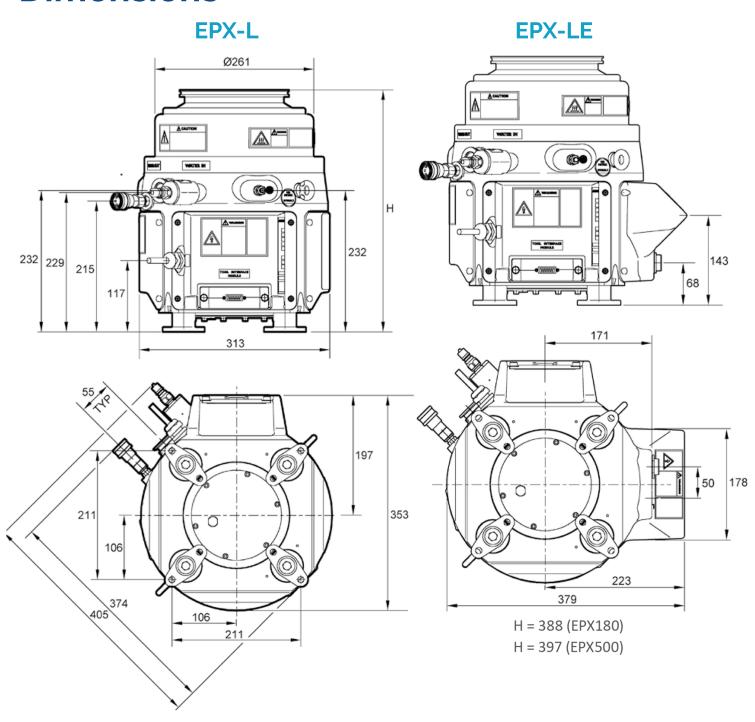
## **Technical Specifications**

		EPX180L/LE	EPX180N/NE
Peak speed	m³h <sup>-1</sup>	175	175
	cfm	106	106
	l min <sup>-1</sup>	3000	3000
Ultimate vacuum	mbar	<1 x 10 <sup>-4</sup>	<1 x 10 <sup>-4</sup>
	Torr	<7 x 10 <sup>-5</sup>	<7 x 10 <sup>-5</sup>
	Pa	<1 x 10 <sup>-2</sup>	<1 x 10 <sup>-2</sup>
Typical nitrogen consumption	slm	0	25
Inlet/outlet connection		ISO63/NW25	ISO63/NW25
Noise	dB(A)	56	56
Cooling water consumption	l/h	120	120
Weight	kg	45	47
Power to Ultimate	kW	1.4	1.6
(in typical fab install at 700 Torr backing)	kW	1.3	1.5
* Two outlet connections are required			

		EPX500L/LE	EPX500N/NE
Peak speed	m³h <sup>-1</sup>	500	500
	cfm	295	295
	l min <sup>-1</sup>	8335	8335
Ultimate vacuum	mbar	<1 x 10 <sup>-6</sup>	<1 x 10 <sup>-6</sup>
	Torr	<7 x 10 <sup>-7</sup>	<7 x 10 <sup>-7</sup>
	Pa	<1 x 10 <sup>-4</sup>	<1 x 10 <sup>-4</sup>
Typical nitrogen consumption	slm	0	25
Inlet/outlet connection		ISO160/NW25	ISO160/NW25
Noise	dB(A)	56	56
Cooling water consumption	l/h	120	120
Weight	kg	45	47
Power to Ultimate	kW	1.6	1.8
(in typical fab install at 700 Torr backing)	kW	1.5	1.7

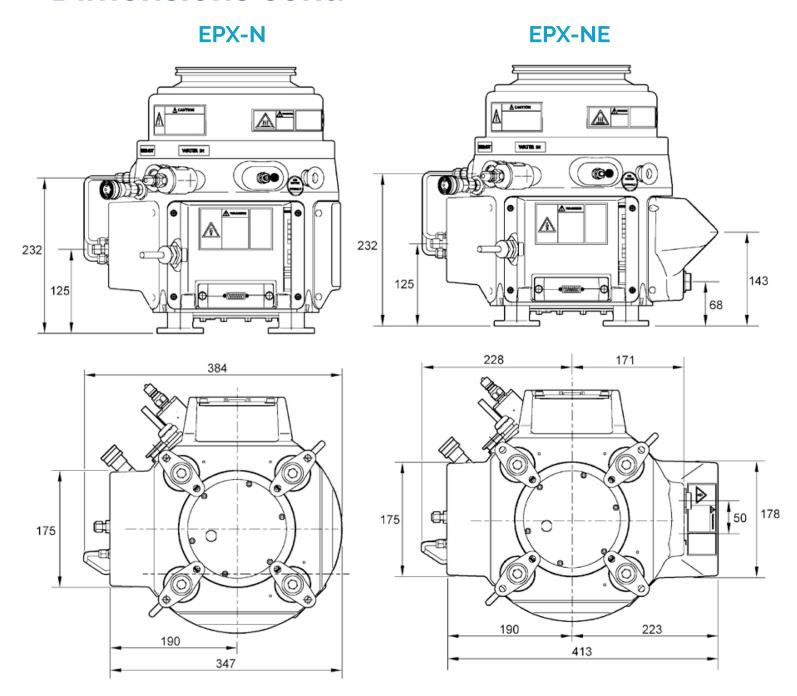
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#### **Dimensions**



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#### **Dimensions cont.**



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#### **Features & Benefits**

- · can be integrated into a process tool or mounted remotely
- integrated electronics provide simple communication connections
- supports clean & light duty semiconductor processing applications
- · unique, patented mechanism
- · low ultimate pressure & vibration
- low service cost, zero periodic maintenance
- lightweight, small footprint
- plug & pump tool interface
- wide application range

### **Applications**

semiconductor • ash/strip • implant end station applications

## **Pumping Curves**

